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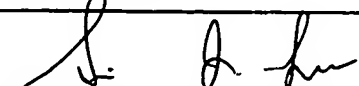
Substitute for form 1449A/PTO		U.S. Patent and Trademark Office U.S. Department of Commerce		COMPLETE IF KNOWN	
INFORMATION DISCLOSURE CITATION (use as many sheets as necessary)				Application Number	10/
				Filing Date	December 12, 2003
				First Named Inventor	Steven A. Soper
				Art Unit	
				Examiner Name	
Sheet	1	of	2	Attorney Docket No.	0023.1 Soper

U.S. PATENT DOCUMENTS						
Exam. Initial	Document No.	Date	Name	Class	Subcl.	File Date
SJL	6,436,615	8/02	Brandow <i>et al.</i>	430	324	6/25/99
↓	5,051,312	9/91	Allmer	428	458	

Note: Copies of U.S. Patents are not enclosed. See OG Notice of August 5, 2003.

FOREIGN PATENT DOCUMENTS				
Exam. Initial	Foreign Patent Document Country Code / Number / Kind	Publication Date MM-DD-YY	Name of Patentee or Applicant of Cited Document	Translation ?
SJL	WO 02/18288	03-07-02	Hevesi <i>et al.</i>	
↓	WO 00/56808	09-28-00	Larsson <i>et al.</i>	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
SJL	M. Adams <i>et al.</i> , "Surface modification of bisphenol-A-polycarbonate by far-UV radiation. Part I: In vacuum," Polymer Degradation and Stability, vol. 41, pp. 265-273 (1993)
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	A. Henry <i>et al.</i> , "Surface modification of poly(methyl methacrylate) used in the fabrication of microanalytical devices," Anal. Chem., vol. 72, pp. 5331-5337 (2000)
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↓	T. Johnson <i>et al.</i> , "Chemical mapping of hot-embossed and UV-laser-ablated microchannels in poly(methyl methacrylate) using carboxylate specific fluorescent probes," Appl. Surf. Sci., vol. 181, pp. 149-159 (2001)

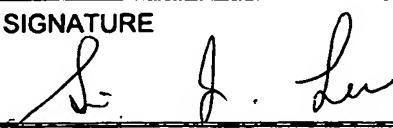
EXAMINER SIGNATURE	DATE CONSIDERED
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* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw a line through the citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
SJL	Johnson, T. <i>et al.</i> , "Laser modification of preformed polymer microchannels: Application to reduce band broadening around turns subject to electrokinetic flow," <i>Anal. Chem.</i> , vol. 73, pp. 3656-3661 (2001)
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↓	Zhang, J. <i>et al.</i> , "Modification of polymers with UV excimer radiation from lasers and lamps," <i>J. Adhesion Sci.</i> , vol. 8, pp. 1179-1210 (1994)

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